

PATENT APPLICATION
IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of

Docket No: Q87270

Tsunehisa NAMIKI, et al.

Appln. No.: 10/530,357

Group Art Unit: 3742

Confirmation No.: 7770

Examiner: Quang T. Van

Filed: September 23, 2005

For: METHOD OF FORMING A METAL OXIDE FILM AND MICROWAVE POWER
SOURCE DEVICE USED FOR THE ABOVE METHOD

RESPONSE TO RESTRICTION REQUIREMENT

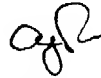
Mail Stop Amendment
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

Responsive to the outstanding Restriction Requirement of August 17, 2007, Applicant elects Group I, claims 1-16 (drawn to a method for forming a metal oxide film) for prosecution, without traverse. Applicant also reserves the right to file a Divisional Application directed to the non-elected subject matter.

The USPTO is directed and authorized to charge all required fees, except for the Issue Fee and the Publication Fee, to Deposit Account No. 19-4880. Please also credit any overpayments to said Deposit Account.

Respectfully submitted,



Abraham J. Rosner
Registration No. 33,276

SUGHRUE MION, PLLC
Telephone: (202) 293-7060
Facsimile: (202) 293-7860

WASHINGTON OFFICE

23373

CUSTOMER NUMBER

Date: August 28, 2007